

**Search Notes**

Application/Control No.

10/804,020

Examiner

Richard H. Kim

Applicant(s)/Patent under  
Reexamination

JEOUNG, HUN

Art Unit

2871

**SEARCHED**

Class	Subclass	Date	Examiner

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
East Text Search (349/38,141;349/\$)- JPO,EPO,USPAT,PGPUB-see printout	12/21/2005	RHK